

Supporting information

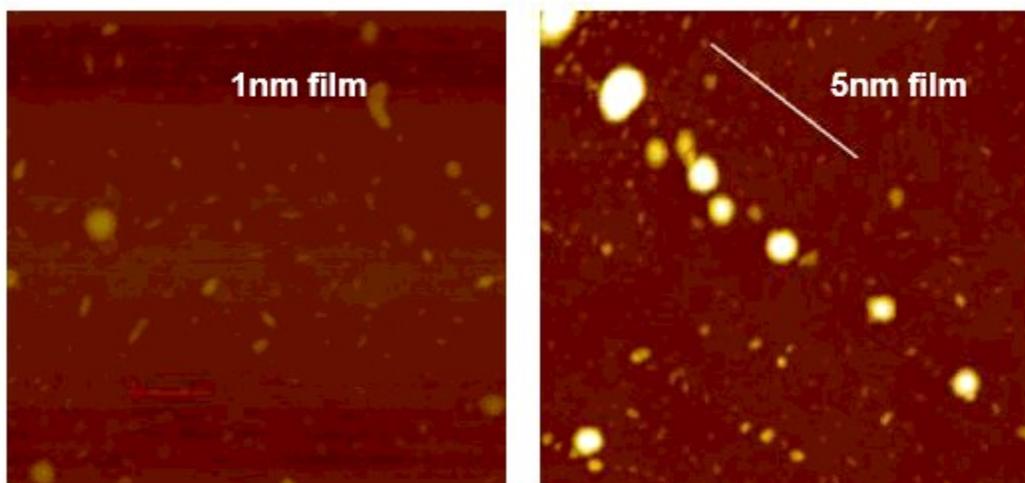
## **Baking soda: Ultra cheap and air stable electron injection layer for organic electron devices**

Dang Xuan Long, Yong-Young Noh\*

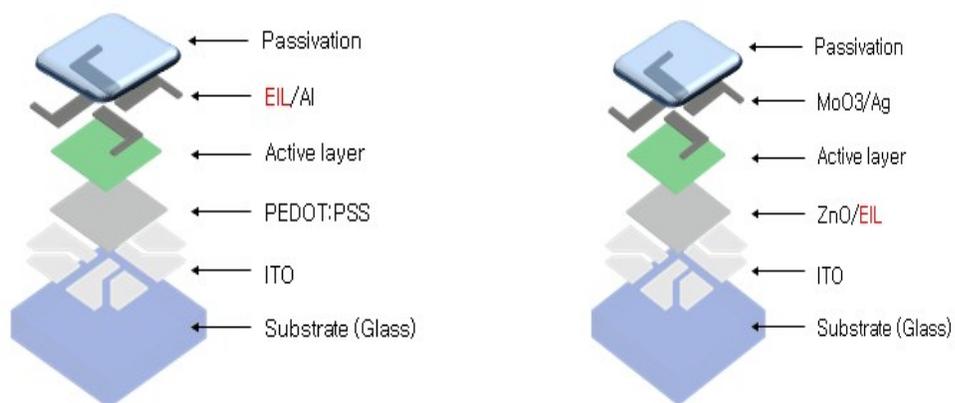
*Department of Energy and Materials Engineering, Dongguk University, 30 Pildong-ro, 1-gil, Jung-gu, Seoul 04620, Republic of Korea.*

**Table S1.** Work Function of various bare conducting electrodes and NaHCO<sub>3</sub> deposited electrode surface, as independently measured by ACII in a pristine condition and after 8 weeks of exposure to air.

Electrode	ACII- Wf(eV)		After 8 week
	Pristine	Evaporated NaHCO <sub>3</sub> (1nm)	Evaporated NaHCO <sub>3</sub> (1nm)
ITO	4.95	4.03	4.19
PEDOT:PSS	5.23	4.36	4.47
Au	5.56	4.65	4.72
Al	4.61	3.88	4.05



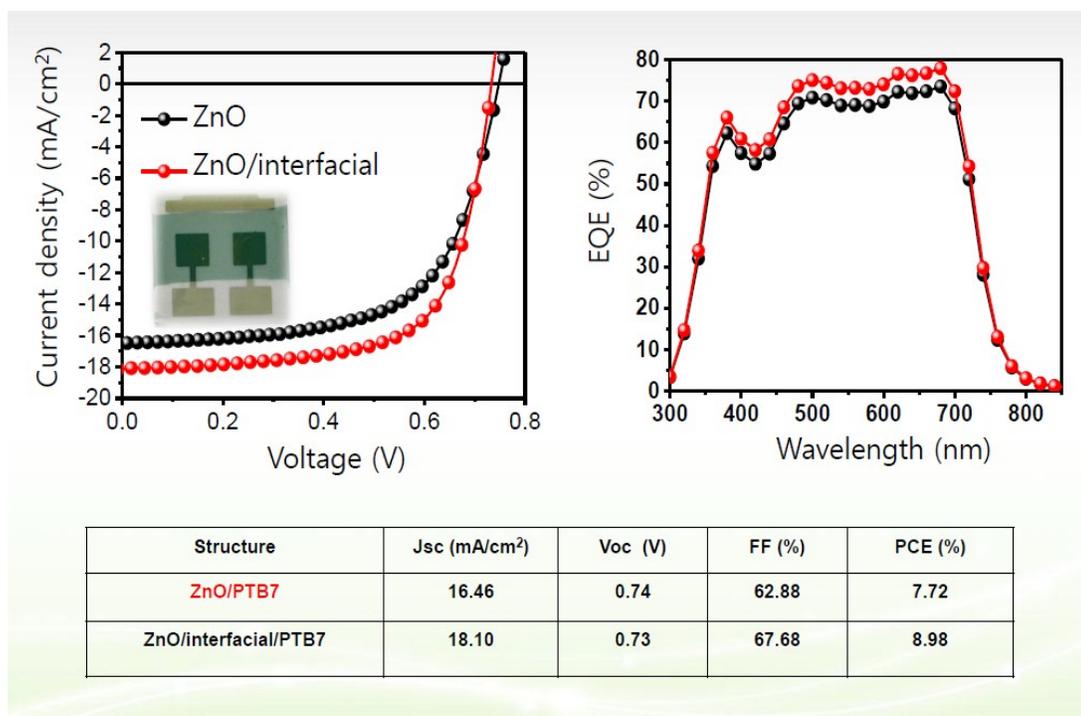
**Figure S1.** Atomic force microscope image of spin coated NaHCO<sub>3</sub> film with 1 nm and 5 nm thickness on ITO substrate (2 μm × 2 μm)



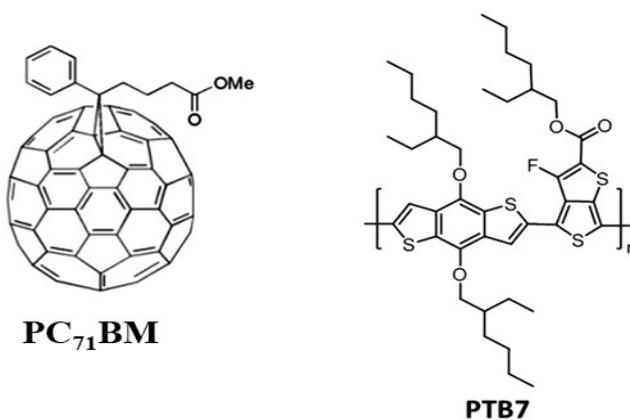
1. ITO/PEDOT:PSS(5000rpm)/Active/ LiF(1nm)-Al
2. ITO/PEDOT:PSS(5000rpm)/Active/ NaHCO<sub>3</sub>(1nm)-Al
3. ITO/PEDOT:PSS(5000rpm)/Active/ BaCl<sub>2</sub>(1nm)-Al
4. ITO/PEDOT:PSS(5000rpm)/Active/ CsF(1nm)-Al

1. ITO/ZnO/PEI(5000rpm)/Active/ MoO<sub>3</sub>(5nm)/Ag(70nm)
2. ITO/ZnO/NaHCO<sub>3</sub>(5000rpm)/Active/ MoO<sub>3</sub>(5nm)/Ag(70nm)
3. ITO/ZnO/ CsF(5000rpm)/Active/ MoO<sub>3</sub>(5nm)/Ag(70nm)
4. ITO/ZnO/BaCl<sub>2</sub>(5000rpm)/Active/ MoO<sub>3</sub>(5nm)/Ag(70nm)

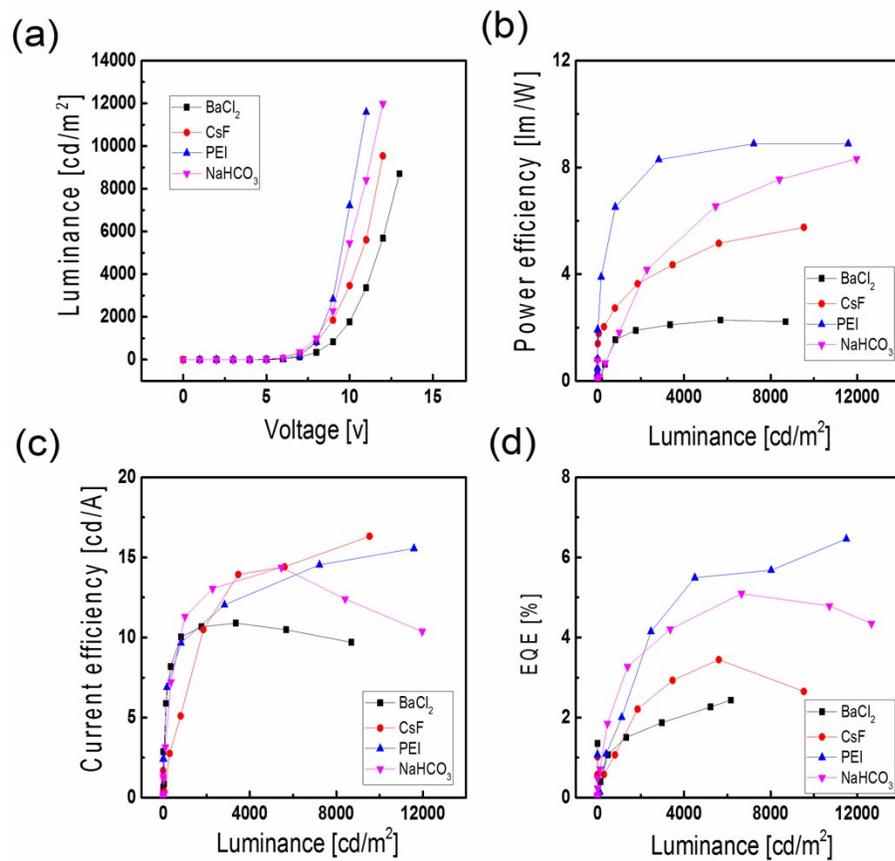
**Figure S2.** Conventional and inverse structures for OLED and OPD devices



**Figure S3.** Devices using ITO/ZnO with and without NaHCO<sub>3</sub> as the bottom electrode. J-V characteristics of these devices inset at low voltage.



**Figure S4.** Structures of the acceptor and donor in bulk heterojunction organic photovoltaic cells.



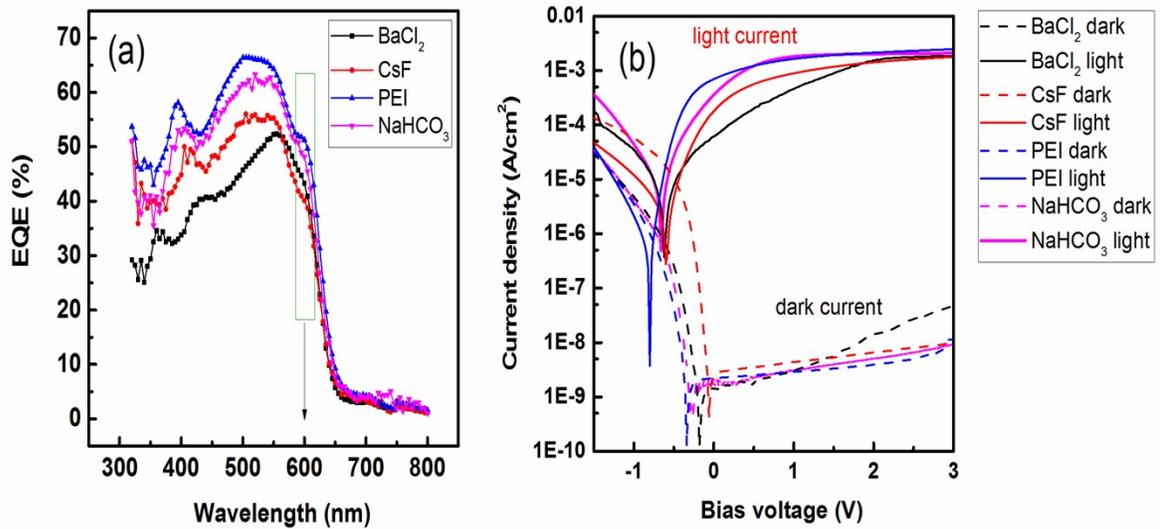
**Figure S5.** Performance of the Ir(ppy)<sub>3</sub>-based, solution processable OLED devices using various EILs. The OLED structure was ITO/ZnO/EILs/PVK:PBD:Ir(ppy)<sub>3</sub>/MoO<sub>3</sub>/Ag.

**Table S2.** Summary of the performance of inverse structure OLEDs with EILs with different areal number densities. The OLED structure was ITO/ZnO/EILs/PVK:PBD:Ir(ppy)<sub>3</sub>/MoO<sub>3</sub>/Ag

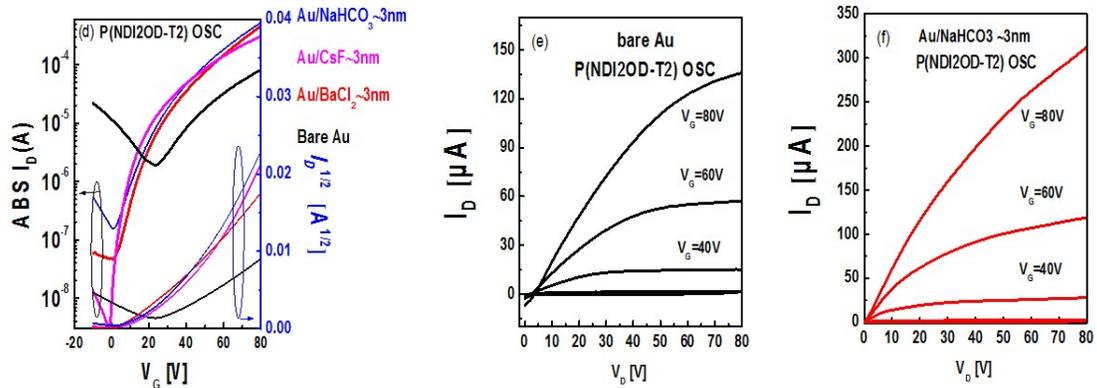
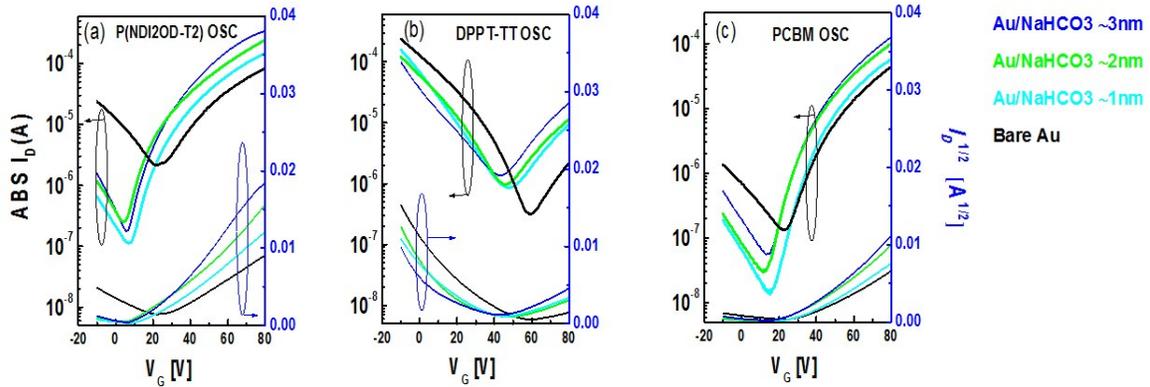
Sample	Turn-on voltage (V)	Max. EQE (%)	Max. luminous efficiency(cd/A)	Max. power efficiency (lm/W)
1 (BaCl <sub>2</sub> )	7.3	2.3	11.2	2.1
2 (CsF)	6.8	3.7	16.1	5.7
3 (PEI)	5.9	5.1	15.8	8.4
4 (NaHCO <sub>3</sub> )	6.1	6.2	14.5	7.9

**Table S3.** Summary of the performance of OPDs with EILs with low bias voltage. The inverted devices are glass/ITO/ZnO/EIL/P3HT:PC60BM/MoO<sub>3</sub>/Ag. Conventional structure devices are glass/ITO/PEDOT:PSS/P3HT:PC60BM/EILs/Al.

Sample	J photo (A/cm <sup>2</sup> )	J dark (A/cm <sup>2</sup> )	R (mA/W)	SNR (a.u)	NEP (W)	D* (Jones)	EQE (%)
Inverted structure (1V)							
BaCl <sub>2</sub>	5.09.E-04	3.40.E-09	50.9	1.50.E+05	1.95.E-13	1.54.E+12	10.5
CsF	9.88.E-04	4.80.E-09	98.8	2.06.E+05	1.19.E-13	2.52.E+12	20.4
PEI	2.00.E-03	3.39.E-09	200.0	5.90.E+05	4.94.E-14	6.07.E+12	41.3
NaHCO <sub>3</sub>	1.82.E-03	3.25.E-09	182.2	5.61.E+05	5.31.E-14	5.65.E+12	37.7
Convectional structure (-1V)							
BaCl <sub>2</sub>	1.36.E-03	7.69.E-07	135.5	1.76.E+03	1.10.E-12	2.73.E+11	28.0
CsF	1.37.E-03	4.12.E-07	136.6	3.32.E+03	7.98.E-13	3.76.E+11	28.2
LiF	1.61.E-03	9.89.E-08	161.1	1.63.E+04	3.31.E-13	9.05.E+11	33.3
NaHCO <sub>3</sub>	1.74.E-03	4.58.E-08	174.4	3.81.E+04	2.08.E-13	1.44.E+12	36.1



**Figure S6.** Current density versus applied voltage characteristics and external quantum efficiency of organic photodiode with inverted structure under darkness and illumination at 600 nm, 10 mW/cm<sup>2</sup> with different electron injection layers. The inverted devices are glass/ITO/ZnO/EIL/P3HT:PC60BM/MoO<sub>3</sub>/Ag.



**Figure S7.** Transfer characteristics of (a) P(NDI2OD-T2), (b) DPPT-TT and (c) PCBM OFET devices with pristine Au and NaHCO<sub>3</sub>-treated Au eBalectrode (interlayer with varying thickness levels). (d) Comparison of the effects of other interlayers on Au electrode for P(NDI2OD-T2) device. Output characteristics of P(NDI2OD-T2) OFETs device with (e) pristine Au and (f) NaHCO<sub>3</sub>-treated Au electrode.